



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Lee	Docket No.:	2003 P 50816 US
Serial No.:	10/600,661	Art Unit:	TBD
Filed:	June 20, 2003	Examiner:	TBD
For:	Magnetic Tunnel Junction Patterning Using SiC or SiN		

Certificate of Mailing via First Class Mail (37 C.F.R. § 1.8(a))

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Respectfully submitted,

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